



PATENT

Atty. Dkt. No. APPM/008736/DSM/BCVD/JW

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Liu, et al

Serial No.: 10/768,724

Confirmation No.: 5121

Filed: January 30, 2004

For: TECHNIQUES FOR THE USE OF
AMORPHOUS CARBON (APF)
FOR VARIOUS ETCH AND LITHO
INTEGRATION SCHEMES

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Group Art Unit: 1765

Examiner: Chen, Eric Brice

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>1/17</u> , 2006 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>1/17/06</u> Date	<u>Keith M. Tackett</u> Keith M. Tackett

RESPONSE TO OFFICE ACTION DATED OCTOBER 17, 2005

In response to the Office Action dated October 17, 2005, having a shortened statutory period for response set to expire on January 17, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/008736/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper. **Remarks** begin on page 8 of this paper.